## Notice of References Cited Application/Control No. 10/659,299 Applicant(s)/Patent Under Reexamination HASHIMOTO ET AL. Examiner Julie Anne Watko Art Unit Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.